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## BIB DATA SHEET

CONFIRMATION NO. 2213

<b>SERIAL NUMBER</b> 10/598,933	<b>FILING or 371(c) DATE</b> 09/14/2006 <b>RULE</b>	<b>CLASS</b> 505	<b>GROUP ART UNIT</b> 2886	<b>ATTORNEY DOCKET NO.</b> PA214WP002
<b>APPLICANTS</b> Fumi Nabeshima, Hiratsuka-shi, JAPAN; Kazuya Togashi, Hiratsuka-shi, JAPAN; Hiroshi Jiken, Hiratsuka-shi, JAPAN; Yoshinori Suenaga, Hiratsuka-shi, JAPAN;				
<b>** CONTINUING DATA *****</b> This application is a CON of PCT/JP05/07120 04/13/2005				
<b>** FOREIGN APPLICATIONS *****</b> JAPAN 2004-117910 04/13/2004				
<b>** IF REQUIRED, FOREIGN FILING LICENSE GRANTED **</b> 06/21/2007				
Foreign Priority claimed <input checked="" type="checkbox"/> Yes <input type="checkbox"/> No 35 USC 119(a-d) conditions met <input checked="" type="checkbox"/> Yes <input type="checkbox"/> No Verified and Acknowledged _____ Examiner's Signature	<input checked="" type="checkbox"/> Met after Allowance tc Initials	<b>STATE OR COUNTRY</b> JAPAN	<b>SHEETS DRAWINGS</b> 6	<b>TOTAL CLAIMS</b> 6
<b>INDEPENDENT CLAIMS</b> 2				
<b>ADDRESS</b> JOSEPH P. FARRAR 2-4-6 TSUKUDA SUITE 709 CHUO-KU, TOKYO, 104-0051 JAPAN				
<b>TITLE</b> SEMICONDUCTOR WAFER INSPECTION DEVICE AND METHOD				
<b>FILING FEE RECEIVED</b> 1430	FEES: Authority has been given in Paper No. _____ to charge/credit DEPOSIT ACCOUNT No. _____ for following:		<input type="checkbox"/> All Fees <input type="checkbox"/> 1.16 Fees (Filing) <input type="checkbox"/> 1.17 Fees (Processing Ext. of time) <input type="checkbox"/> 1.18 Fees (Issue) <input type="checkbox"/> Other _____ <input type="checkbox"/> Credit	